

10/009521

FILED UNDER 35 U.S.C. 371

PATENT NUMBER and  
ISSUE DATE

## U.S. UTILITY Patent Application

APPL NUM 10009521	FILING DATE 12/11/2001	CLASS 173.26	SUBCLASS 655	GAU 173.26	EXAMINER VALENTINE
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**\*\*APPLICANTS:** Izuo Shinichi; Ohji Hiroshi; Tsutsumi Kazuhiko; French Pattrick;**\*\*CONTINUING DATA VERIFIED:**

THIS APPLICATION IS A 371 OF PCT/JP00/03307 05/24/2000

**\*\* FOREIGN APPLICATIONS VERIFIED:**

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PG-PUB DO NOT PUBLISH ☐RESCIND ☐Foreign priority claimed ☐ yes ☐ no35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

401479

TITLE : Method and apparatus for radiation assisted electrochemical etching and etched product

U.S. DEPT. OF COMM./PAT. &amp; TM.-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Assistant Examiner	Total Claims
			Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drawn	Fig. Drawn
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner	Application Examiner
		<b>PREPARED FOR ISSUE</b>	
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